

**INFORMATION DISCLOSURE CITATION**  
(Use several sheets if necessary)

Docket Number (Optional)

**SEC.889D**

Application Number

**NEW**

Applicant(s)

**Moon-hee LEE et al.**

Filing Date

**January 20, 2004**

Group Art Unit

**To Be Assigned**

**U.S. PATENT DOCUMENTS**

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<b>MK</b>	<b>A</b>	<b>5,091,068</b>	<b>01/1992</b>	<b>ENDO et al.</b>			
	<b>B</b>	<b>4,909,914</b>	<b>03/1990</b>	<b>CHIBA et al.</b>			
	<b>C</b>	<b>5,125,979</b>	<b>06/1992</b>	<b>SWAIN et al.</b>			
	<b>D</b>	<b>4,209,028</b>	<b>05/1993</b>	<b>MCDERMOTT et al.</b>			
	<b>E</b>	<b>5,315,793</b>	<b>05/1994</b>	<b>PETERSON et al.</b>			
	<b>F</b>	<b>5,613,509</b>	<b>03/1997</b>	<b>KLOB et al.</b>			
	<b>G</b>	<b>5,967,156</b>	<b>10/19/1999</b>	<b>ROSE et al.</b>			
<b>MK</b>	<b>H</b>	<b>5,795,892</b>	<b>06/02/1998</b>	<b>WANG et al.</b>			

**FOREIGN PATENT DOCUMENTS**

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
<b>MK</b>	<b>I</b>	<b>JP2000315672</b>	<b>11/14/2000</b>	<b>JAPAN</b>				

**OTHER DOCUMENTS** (Including Author, Title, Date, Pertinent Pages, Etc.)


EXAMINER

*[Signature]*

DATE CONSIDERED

**03/18/2005**

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

*DUPLICATE*